

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) 09780001AA		Application Number unknown		
				Applicant(s) Masahiko Ishida et al.				
				Filing Date March 22, 2006		Group Art Unit unknown		
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
U.S. PATENT APPLICATION PUBLICATIONS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		2003-238123	08.27.2003	NEC CORP.	Int. Cl		✓	
		2003-017508	17.01.2003	NEC CORP.	Int. Cl		✓	
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
		J. Fujita et al. Graphitization of FE-doped amorphous carbon pillars grown by focused-ion-beam-induced chemical-vapor deposition, Journal of Vacuum Science & Technology B, second series, volume 20, number 6,11/2002; pages 2686-2689						
		Yoshikazu Homma et al. Growth of suspended carbon nanotube networks on 100-nm-scale silicon pillars; AApplied Physics Letters, volume 81, number 12; 09.16.2002; pages 2261-2263						
EXAMINER				DATE CONSIDERED				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional) 09780001AA	Application Number unknown
	Applicant(s) NMasahiko Ishida et al.	
	Filing Date March 22, 2006	Group Art Unit unknown

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

		Seizo Kinoshita et al., "Ichi Seigio Seicho Carbon Nanotube ni yoru Shitsuon Coulomb Blockade", The Institute of Electronics, Information and Communication Engineers Gijutsu Kenkyu Hokoku, 29 January, 2002 (29.01.02), Vol.101, No.618, pages 47 to 52

EXAMINER	DATE CONSIDERED
----------	-----------------

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.